UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Bernd Borchert

Serial No.:

09/944,823

Filed:

August 31, 2001

For:

SEMICONDUCTOR LASER CHIP AND METHOD FOR

FABRICATING A SEMICONDUCTOR LASER CHIP

Confirmation No.:

3378

Group Art Unit:

2828

Examiner:

Delma R. Flores Ruiz

Attorney Docket No.: 32226.12

Additional Fees:

Charge to Deposit Account 023732

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir or Madam:

AMENDMENT AND RESPONSE

This paper is being filed in response to the Office Action mailed December 3, 2003. Please amend the above-identified application as follows:

CERTIFICATE OF MAILING

I hereby certify that this document is being deposited with the United States Postal Service as First Class Mail, in an envelope addressed to Mail Stop Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date indicated